Chinastandards.org

SJ

INDUSTRY STANDARD OF THE PEOPLE'S REPUBLIC OF CHINA

SJ/T 11206-1999

Measurement method of double-aperture and multi-aperture cores made of magnetic oxides

磁性氧化物制成的双孔及多孔磁芯测量方法

(English Translation)

Issued on: August 26, 1999 **Implemented on: December 1, 1999**

Issued by: Ministry of Information Industry of the People's Republic of China

Preview: page 1 of 2 shown, full document available. Complete English PDF, instant download:
https://chinastandards.org/standards/sj-t-11206-1999

Chinastandards.org

Table of Contents

Document data

1 Document data

Sector: Electronics (industry standard).

Issuing body: Ministry of Information Industry of the People's Republic of China.

Date of issue: 1999-08-26.

Date of implementation: 1999-12-01.

Status: valid.

Preview: page 2 of 2 shown, full document available. Complete English PDF, instant download:
https://chinastandards.org/standards/sj-t-11206-1999